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CONFIRMATION NO. 8716

SERIAL NUMBER 09/882,323	FILING DATE 06/13/2001 RULE	CLASS 216	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. 002772 USA P 01/ETCH/SILI
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APPLICANTS

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**** CONTINUING DATA *******

THIS APPLICATION IS A CIP OF 09/291,682 04/13/1999 ABN

**** FOREIGN APPLICATIONS *******

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 07/03/2001

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 3	TOTAL CLAIMS 87	INDEPENDENT CLAIMS 8
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>[Initials]</i>		

ADDRESS

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APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
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TITLE

Method of etching silicon nitride

FILING FEE RECEIVED 2446	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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